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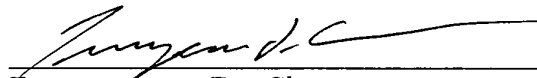
Applicants: Toru IMORI et al
 Title METAL PLATING METHOD, PRETREATMENT AGENT, AND
 SEMICONDUCTOR WAFER AND SEMICONDUCTOR DEVICE
 OBTAINED USING THESE
 Serial No. 10/767 697 Group: 2812
 Confirmation No.: 5592
 Filed : January 29, 2004 Examiner: Unknown
 Atty. Docket No.: Komatsu Case 267A

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

FIRST CLASS MAILING CERTIFICATE

Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service under 37 CFR 1.8 as first class mail in an envelope addressed to: Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450, on March 18, 2005.

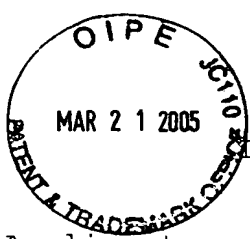

 Terryence F. Chapman

TFC/smd

FLYNN, THIEL, BOUTELL	Dale H. Thiel	Reg. No. 24 323
& TANIS, P.C.	David G. Boutell	Reg. No. 25 072
2026 Rambling Road	Ronald J. Tanis	Reg. No. 22 724
Kalamazoo, MI 49008-1631	Terryence F. Chapman	Reg. No. 32 549
Phone: (269) 381-1156	Mark L. Maki	Reg. No. 36 589
Fax: (269) 381-5465	Liane L. Churney	Reg. No. 40 694
	Brian R. Tumm	Reg. No. 36 328
	Steven R. Thiel	Reg. No. 53 685
	Donald J. Wallace	Reg. No. 43 977
	Sidney B. Williams, Jr.	Reg. No. 24 949

Correspondence: Information Disclosure Statement
 dated March 18, 2005
 including enclosures listed thereon

190.05/03



PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

March 18, 2005

Applicants : Toru IMORI et al

For : METAL PLATING METHOD, PRETREATMENT AGENT, AND
SEMICONDUCTOR WAFER AND SEMICONDUCTOR DEVICE
OBTAINED USING THESE

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Examiner: Unknown

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INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the provisions of Rules 1.97(b)(3) and 1.98, enclosed herewith is Form PTO-1449 and the references cited thereon. This application is a CIP of parent application Serial No. 10/169 778, filed July 2, 2002 (Attorney's reference Komatsu Case 267). The documents listed on the attached Form PTO-1449 were supplied to the Patent Office in the above-identified parent application. Further comment at this point in time should not be necessary.

Further consideration is respectfully solicited.

Respectfully submitted,

Terryence F. Chapman

TFC/smd

FLYNN, THIEL, BOUTELL
& TANIS, P.C.
2026 Rambling Road
Kalamazoo, MI 49008-1631
Phone: (269) 381-1156
Fax: (269) 381-5465

Dale H. Thiel
David G. Boutell
Ronald J. Tanis
Terryence F. Chapman
Mark L. Maki
Liane L. Churney
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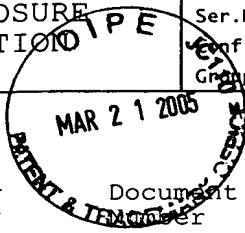
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Reg. No. 43 977
Reg. No. 24 949

Encl: Form PTO-1449 and one copy of each reference listed
thereon

110.0703

INFORMATION
DISCLOSURE
CITATION

Applicant: Toru IMORI et al
Ser.No. : 10/767 697 Filed : January 29, 2004
Ref. No.: 5592 Atty.Ref.: Komatsu Case 267A
Group : 2812



U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Date	Name	Class	Sub Class	Filing Date
AA	4 986 848	1/1991	YAMAMOTO et al			
AB						
AC						

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Sub Class	Translation Yes No
AD	59-52701	12/1984	Japan	English Abstract	attached	
AE	60-181294	9/1985	Japan	English Abstract	attached	
AF	61-194183	8/1986	Japan	English Abstract	attached	
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AH	6-256358	9/1994	Japan	English Abstract	attached	
AI	63-227784	9/1988	Japan	English Abstract	attached	
AJ	63-270474	11/1988	Japan	English Abstract	attached	
AK	11-92482	4/1999	Japan	English Abstract	attached	
AL	1-117089	5/1989	Japan	English Abstract	attached	
AM	11-288940	10/1999	Japan	English Abstract	attached	
AN	2 324 538	10/1998	Great Britain			

OTHER DOCUMENTS (Including Author, Title, Date, Pages, Etc.)

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AP	

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.